

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Den Toonder, *et al.* Docket No.: EPC-018
Serial No.: 10/578,027 Examiner: TBD
Filed: April 27, 2006 Art Unit: TBD
For: Radio-Frequency Microelectromechanical Systems and a Method of Manufacturing Such Systems

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a that may be considered material to the examination of the above-identified application. Copies of the U.S. Patent and Publications cited are not being submitted. However, Applicants have included copies of the foreign patents.

No fee is due at this time, as this Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3), before the mailing of a first Office Action on the merits.

Respectfully submitted,



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